



## THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hitoshi YAMADA et al.

Group Art Unit: 1762

Serial Number: 10/642,271

Examiner: Marianne L. Padgett

Filed: August 18, 2003

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For

METHOD OF FORMING METAL OXIDE FILM AND METHOD

FOR FORMING SECONDARY ELECTRON EMISSION FILM IN

**GAS DISCHARGE TUBE** 

Attorney Docket Number:

030933

**Customer Number:** 

38834

## **SUBMISSION OF TERMINAL DISCLAIMER**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 October 6, 2006

Sir:

Submitted herewith is a Terminal Disclaimer. Also attached is the fee under 37 C.F.R. §1.20(d).

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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